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FTO/SB/21 (08-03)

	PrRt		Applica	ation Number	10/020,46	1
TRANSMITTAL			Filing (	Date	Decembe	r 14, 2001
į F	ORM		First N	amed Inventor	M'Saad, H	lichem
(to be used for all correspondence after initial filing)			Art Un	it	1731	
			Exami	ner Name	Hoffmann, John M.	
Total Number of Pages in This Submission			Attorne	ey Docket Number	A6123/T4	3700
ENCLOSURES (Check all that apply)						
Fee Transmittal Form Drawi		☐ Drawin	ng(s)		After A	Allowance Communication to Group
Fee Attached		Licensing-related Papers			l Communication to Board of Appeals terferences	
Amendment/Rep	ly	Petition	ì			l Communication to Group (Appeal , Brief, Reply Brief)
After Final			n to Conv onal Appl		☐ Propri	etary Information
			Power of Attorney, Revocation Change of Correspondence Address		Status	Letter
Extension of Time Request		Termin	Terminal Disclaimer			Enclosure(s) e Identify below):
Express Abandonment Request		equest for Refund  D, Number of CD(s)		Return Pos references	stcard, copies of elevan (11) cited	
Certified Copy of Priority		Rema	rks	The Commissioner is a Account 20-1430.	authorized to	charge any additional fees to Deposit
Response to Missing Parts/ Incomplete Application				I		
Response to Missing Parts under 37 CFR 1.52 or 1.53						
				ICANT, ATTORNEY,	OR AGEN	Τ
Firm or	Townsend and T		ind Crew			
Individual Patrick M. Boucher				Reg. N	o. 44,037	
Signature fatul to						
Date 2004 May 24						
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TOWNSEND and TOWNSEND and CREWILP

Nicole Wartell

<u>PATENT</u>

Attorney Docket No.: A6123/T43700 AMAT No.: 006123/DD/HDP/JW

TTC No.: 016301-043700US

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

HICHEM M'SAAD et al.

Application No.: 10/020,461

Filed: December 14, 2001

For: METHOD OF MANUFACTURING

AN OPTICAL CORE

Examiner: Hoffmann, John M.

Art Unit: 1731

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT UNDER 37

CFR §1.97 and §1.98

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

The references cited on attached form PTO/SB/08A and PTO/SB/08B are being called to the attention of the Examiner. Copies of the references are enclosed. It is respectfully requested that the cited references be expressly considered during the prosecution of this application, and the references be made of record therein and appear among the "references cited" on any patent to issue therefrom.

As provided for by 37 CFR 1.97(g) and (h), no inference should be made that the information and references cited are prior art merely because they are in this statement and no

HICHEM M'SAAD et al. Application No.: 10/020,461

Page 2

representation is being made that a search has been conducted or that this statement encompasses all the possible relevant information.

Applicant believes that <u>no fee is required</u> for submission of this statement. However, if a fee is required, the Commissioner is authorized to deduct such fee from the undersigned's Deposit Account No. 20-1430. Please deduct any additional fees from, or credit any overpayment to, the above-noted Deposit Account.

Respectfully submitted,

Patrick M. Boucher Reg. No. 44,037

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Tel: 303-571-4000 Fax: 303-571-4321

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INFORMATION DISCLOSURE STATEMENT BY APPLICANT

Application Number 10/020,461

Filing Date December 14, 2001

First Named Inventor M'Saad, Hichem

Art Unit 1731

Examiner Name Hoffmann, John M.

Complete if Known

(use as many sheets as necessary)

Sheet 1 of 2 Attorney Docket Number A6123/T43700

	U.S. PATENT DOCUMENTS+						
		Document Number					
Examiner Initials*	Cite No. <sup>1</sup>	Number Kind Code <sup>2</sup> (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear		
	A1	US-4,557,561	12-10-1985	Schneider et al.			
	A2	US-6,154,582	11-28-2000	Bazylenko et al.			
	A3	US-6,194,038 B1	02-27-2001	Rossman			
	A4	US-6,451,686 B1	09-17-2002	Ngai et al			
	A5	US-2003/0113085 A1	06-19-2003	M'Saad et al.			
	A6	US-6,705,124 B2	03-16-2004	Zhong et al.			
	A7	US 2004/0079118 A1	04-29-2004	M'Saad et al.			
	A8	US-					

FOREIGN PATENT DOCUMENTS								
Examiner Cite No.1		Foreign Patent Document			Publication Date	Name of Patentee or	Pages, Columns, Lines, Where Relevant	
	No. <sup>3</sup>	Country Code <sup>3</sup>	Number⁴	Kind Code <sup>8</sup> (if known)	MM-DD-YYYY	Applicant of Cited Document	Passages or Relevant Figures Appear	T⁰
	B1							
	B2							

Examiner Signature	Date Considered	

Substitute for form 1449B/P Complete if Known 10/020,461 Application Number **INFORMATION DISCLOSURE** Filing Date December 14, 2001 STATEMENT BY APPLICANT First Named Inventor M'Saad, Hichem Art Unit 1731 (use as many sheets as necessary) Examiner Name Hoffmann, John M. 2 Sheet of Attorney Docket Number A6123/T43700

Examiner	Cite No.1	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s),				
iniuais *	C1	publisher, city and/or country where published.  MATTHEWS, MANYALIBO J. et al. "Characterization of phosphosilicate thin films using confocal Raman microscopy" Review of Scientific Instruments, May 2000, pp. 2117-2120, Vol. 71, No. 5, American Institute of Physics.				
	C2	VERBEEK, B.H. et al. "Integrated Four-Channel Mach-Zehnder Multi/Demultiplexer Fabricated with Phosphorous Doped SiO2 Waveguides on Si" Journal of Lightwave Technology, June 1988, pp. 1011-1015, Vol. 6, No. 6, IEEE.				
	СЗ	VALETTE, S. et al. "Si-Based Integrated Optics Technologies" Solid State Technology, February 1989, pp. 69-75.				
	C4	VALETTE, S. et al. "State of the art of integrated optics technology at LETI for achieving passive optical components" Journal of Modern Optics, 1988, pp. 993-1005, Vol. 35, No. 6.				
	C5					

Examiner	 Date	
Signature	Considered	

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

Applicant's unique citation designation number (optional). Applicant is to place a check mark here if English language Translation is attached.